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Seiji Kanazawa was born in Usuki, Japan, in 1961. He received the B.Eng., M.Eng., and Ph. D. degrees from Kumamoto University, Kumamoto, Japan, in 1985, 1987, and 1990, respectively.

Since 1990, he has been with Oita University, Oita, Japan, where he is currently Professor with the Faculty of Science and Technology. His research interests are in the areas of electrostatics, air pollution control and wastewater treatment by plasmas, radical measurement, electrohydrodynamics, and material processing using lasers. He is the author of more than 100 peer-reviewed papers and three books.

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